

7/20/04

AF/2823
ITW



US V394057835US)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/042,573 Confirmation No. 6585
Applicant : Kei-Wei Chen
Filed : January 9, 2002
TC/A.U. : 2823
Title : Removal of SiON Residue after CMP

*Please enter.
H/L 7/29/04*

Docket No. : N1085-90011
Customer No. : 08933

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING,

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited with the U.S. Postal Service in an envelope as "EXPRESS MAIL POST OFFICE TO ADDRESSEE" service under 37 CFR § 1.10, Mailing Label Number as listed above, addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

Richard A. Paikoff
Richard A. Paikoff, Reg. No. 34,892

7/19/04
Date

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.116(a)

Sir:

In response to the Office Action of May 3, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.